

Attv. Dkt. No. 39153/306 (F0793)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

7/16/01 #2(T,DS

Title:

Piao et al.

CONFIGURABLE RETICLE FOR

LITHOGRAPHY AND A METHOD OF MAKING INTEGRATED

CIRCUITS USING SUCH A RETICLE

RE

Appl. No.: 09/775,059

Filing Date: 02/01/2001

Examiner:

unknown

Art Unit: unknown

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on

the date below

Kristine Lancelle

Windows Infinited Nathor

MAY 15 2001 TC 2800 MAIL ROOM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. §§ 1.97-98 and in accordance with the duty of disclosure under 37 C.F.R. §1.56, Applicant submits herewith the references listed on the attached Form PTO-1449 to the Examiner such that they may be considered and made of record in the above-identified application. A copy of each reference is enclosed.

Respectfully submitted,

Data

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